



Docket No.: 50090-250

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventive Application of

Kimio HAGI et al.

Serial No.: 09/732,891

Group Art Unit: 2836

Filed: December 11, 2000

Examiner: Isabel Rodriguez

For: ELECTROSTATIC CHUCKING SYSTEM, AND APPARATUS AND  
METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE  
USING THE ELECTROSTATIC CHUCKING SYSTEM

THE COMMISSIONER FOR PATENTS AND TRADEMARKS  
Washington, DC 20231

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

- ☒ No additional fee is required.  
☐ Applicant is entitled to small entity status under 37 CFR 1.27  
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	7	20	0	\$18.00 =	\$0.00
Independent Claims	3	3	0	\$84.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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